

3 IDS
Dt: AUG 17/01
6-20-01
Docket: 0819-548



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re New Patent Application of)
Mitsuru TANABE)
Japanese Priority Application No. 2000-119604) Attn: Applications
Japanese Priority Date: April 20, 2000) Branch
For: MICROSTRIP LINE, METHOD FOR)
FABRICATING THE SAME, INDUCTOR)
ELEMENT, AND RF SEMICONDUCTOR)
DEVICE) Date: April 20, 2001

INFORMATION DISCLOSURE STATEMENT

Honorable Commissioner for Patents
Washington, D.C. 20231


Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, it is requested that the references listed on the attached Form PTO-1449 be made of record in the above-identified application.

At least some of the references listed on the attached Form PTO-1449 are discussed in the specification of the subject application.

Copies of the references are submitted herewith in accordance with 37 C.F.R. 1.98(a).

Respectfully submitted,


Eric J. Robinson
Registration No. 38,285

NIXON PEABODY LLP
8180 Greensboro Drive, Suite 800
McLean, Virginia 22102
(703) 790-9110